IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re P	atent A	pplica	ition of:						
Hiroyu	ki HIGL	JCHI							
Applica	ation N	0.:		Group Art Unit: Not Yet Assigned					
Filed:	Noven	nber 1	3, 2003	Examiner: Not Yet Assigned					
For:	MULT	I-CYC	LE PATH ANALYZING METHO	D					
	INFORMATION DISCLOSURE STATEMENT								
Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450									
Sir:									
In accordance with the duty of disclosure provisions of 37 CFR § 1.56, there is hereby provided certain information which the Examiner may consider material to the examination of the subject U.S. patent application. It is requested that the Examiner make this information of record fit is deemed material to the examination of the subject application.									
	Enclosures accomp		osures accompanying this Infor	mation Disclosure Statement are:					
	1b. 1c. 1d.		application or a PCT Internatio English language translation (c each non-English language pu Explanations of Relevancy of F	complete or relevant portion(s)) attached to					
	2. 🛚			a concise explanation of what is presently each non-English language publication is					
	2a.		enclosed "English-language ve indicates the degree of relevan 609, Minimum Requirements for	s 2a, 2b, 2c and/or 2d) sh language publications were cited on the ersion of the search report or action which ace found by the foreign office". (See MPEP or an Information Disclosure Statement, Part Relevance, pp. 600-100 to 600-101, Rev. 1,					
	2h	\boxtimes	set forth in the application.						

			English language translation (complete or relevant to each non-English language publication. ent 1(e), hereto.
3.	to be, ma (other tha	iterial to patentability ran search report(s) fro	information cited in this Statement is, or is considered nor a representation that a search has been made m a counterpart foreign application or a PCT submitted herewith). 37 CFR §§ 1.97(g) and (h).
			Respectfully submitted,
			STAAS & HALSEY LLP
Dated: 1	November 1	3, 2003	By: Blandel Ble
1201 New Washing Telephor		., N.W., Suite 700 0005 4-1500	J. Randall Beckers Registration No. 30,358

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO. 826.1903	APPLICATION NO.
FIRST NAMED INVENTOR	
Hirovuki HIGUCHI	

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

and not considered. Include copy of this form with next communication to applicant.

FILING DATE	GROUP ART UNIT
November 13, 2003	Choor And Chin

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	АВ		-				
	AC						
	AD				,		
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSI YES	LATION NO
AG							
АН							
Al							
AJ	-						
AK							
AL							

OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

	AM	H. HIGUCHI, "An Implication-based Method to Detect Multi-Cycle Paths in Large Sequential Circuits", In Proceedings of the 39 th ACM/IEEE Design Automation Conference, pages 164-169.
	AN	K. NAKAMURA, et al., "Waiting False Path Analysis of Sequential Logic Circuits for Performance Optimization", IEEE/ACM ICCAD 98 pp. 392-395, 2002
	AO	S. DAVADAS et al., "Logic Synthesis", p. 236-241, McGraw-Hill, 1994

EXAMINER	DATE CONSIDERED				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance					